## **CERTIFICATE OF MAILING**

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December 20, 2000
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Paul E. Rauch, Ph.D.

Name of Applicant, Assignee or Registered Representative

Signature

December 20, 2000
Date of Signature

Our Case No. 10200/11

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: James M. CLEEVES	)
Serial No.: 08/581,347	)
Filing Date: December 29, 1995	<ul> <li>Examiner : Portner, V.</li> <li>Group Art Unit No.: 1645</li> <li>)</li> </ul>
For: WAFER TEMPERATURE CONTROL APPARATUS AND METHOD	

## AMENDMENT AND REQUEST FOR RECONSIDERATION

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Responsive to the Official Action of July 20, 2000, Applicant respectfully requests reconsideration in light of the following amendments and remarks.

Paul E. Rauch, Ph.D. Registration No. 38,591 Attorney for Applicant

BRINKS HOFER GILSON & LIONE P.O. BOX 10395 CHICAGO, ILLINOIS 60610 (312) 321-4200

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